



**ELECTRONIC COPY**

LG754586258  
Report verification at igi.org



December 8, 2025  
IGI Report Number **LG754586258**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **9.22 - 9.25 X 5.84 MM**  
**GRADING RESULTS**  
Carat Weight **3.09 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**  
Cut Grade **EXCELLENT**

December 8, 2025  
IGI Report Number **LG754586258**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **9.22 - 9.25 X 5.84 MM**

**GRADING RESULTS**

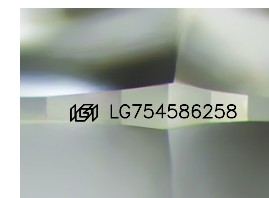
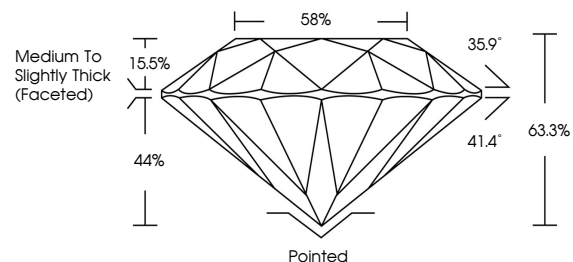
Carat Weight **3.09 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**  
Cut Grade **EXCELLENT**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG754586258**

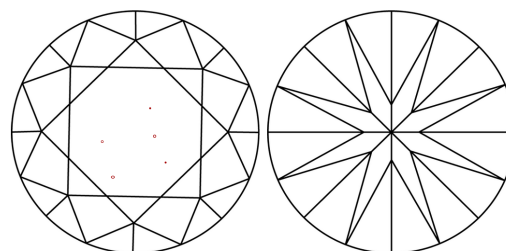
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

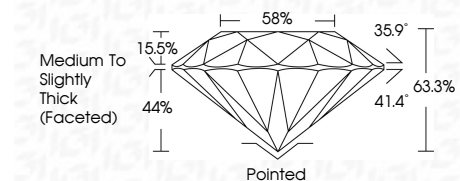
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG754586258**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



December 8, 2025  
IGI Report No **LG754586258**  
**ROUND BRILLIANT**  
9.22 - 9.25 X 5.84 MM  
3.09 CARATS  
F  
Color Grade  
VS 1  
Clarity Grade  
EXCELLENT  
63.3%  
88%  
Medium To Slightly Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
NONE  
Inscriptions(s)  
 LG754586258  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa